



Express Mail No. EV622661191US

Attorney Docket No. 108298715US
Disclosure No. 03-0117.00/US



PTO/SB/08a/b (08-03)
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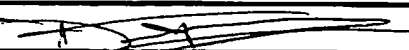
Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete If Known	
				Application Number	10/646,673-Conf. #1020
				Filing Date	August 21, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
Sheet	1	of	13	Attorney Docket Number	108298715US

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.¹	Document Number Number-Kind Code² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
DT		US-09/651,037	Filed 08-30-2000	Mardian	
		US-10/365,085	Filed 02-11-2003	Carpenter et al.	
		US-10/665,099	Filed 09-17-2003	Basceri et al.	
		US-10/665,908	Filed 09-18-2003	Sarigiannis et al.	
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		US-10/687,458	Filed 10-15-2003	Kubista et al.	
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		US-10/767,298	Filed 01-28-2004	Zheng et al.	
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		US-11/018,142	Filed 12-20-2004	Rueger et al.	
		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
DT		US-11/027,825	Filed 12-29-2004	Derderian et al.	

Examiner Signature		Date Considered	4/17/05
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		Examiner Name	T. H. Meeks
		Attorney Docket Number	108298715US
Sheet	2	of	13

	US-11/043,629	Filed 01-25-2005	Rueger et al.	
	US-2001/0010309-A1	08-02-2001	Van Bilsen	
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Sheet	3	of	13	Attorney Docket Number	108298715US

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Sheet	4	of	13	Attorney Docket Number	108298715US

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Sheet	5	of	13	Attorney Docket Number	108298715US

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	US-5,232,749	08-03-1993	Gilton	
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	US-5,380,396	01-10-1995	Shikida et al.	
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	US-5,562,800	10-08-1996	Kawamura	
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

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Sheet	6	of	13	Attorney Docket Number	108298715US

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	US-5,792,269	08-11-1998	Deacon et al.	
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	US-5,833,888	11-10-1998	Arya et al.	
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	US-5,956,613	09-21-1999	Zhao et al.	
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Sheet	7	of	13	Attorney Docket Number	108298715US

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Sheet	8	of	13	Attorney Docket Number	108298715US

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				Art Unit	1762
				Examiner Name	T. H. Meeks
				Attorney Docket Number	108298715US
Sheet	9	of	13		

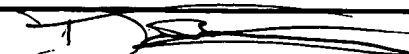
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<input type="checkbox"/>	US-6,596,085	07-22-2003	Schmitt et al.	
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				Art Unit	1762
				Examiner Name	T. H. Meeks
Sheet	10	of	13	Attorney Docket Number	108298715US

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				Art Unit	1762
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